## REPLY UNDER 37 CFR 1.116 EXPEDITED PROCEDURE TECHNOLOGY CENTER 2800

Attorney's Docket No.: 51876.P507

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application for: Examiner: Quovaunda Jefferson

Sung-Kwon Lee, et al. Art Group: 2823

Serial No.: 10/750,001

Filed: December 30, 2003

For: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE

## AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF Commissioner for Patents Post Office Box 1450 Alexandria, Virginia 22313-1450

Ma'am:

In response to the Final Office Action dated January 26, 2007, please amend and the above-captioned application as set forth below.

Amendments to the Claims are reflected in the Listing of Claims and begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.